



Attorney Docket :
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(M)

PATENT

41 3784

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Takahiro SAITO

US Serial No.: 09/752,563

Filed: January 3, 2001

Group Art Unit: 3724

Examiner: C. Goodman

For: METHOD OF CUTTING CSP SUBSTRATES

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

A response to the Office Action dated June 15, 2004 was due by September 15, 2004. A Petition for Extension of Time (one month, large entity) is enclosed, extending the date to October 15, 2004. Therefore, please accept this Amendment as timely filed and fully responsive.

In response to the Office Action dated June 15, 2004, kindly amend the above-identified patent application as follows:

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